

Form PTO 1449
(Modified)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTY DOCKET NO.

248810US2CONT

SERIAL NO.

New Continuation
Application

LIST OF REFERENCES CITED BY APPLICANT

APPLICANT

Geoffrey A. SCARSBROOK, et al.

FILING DATE

Herewith

GROUP

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AO	0 635 584	01/25/1995	EP		X
	AP	0 582 397	02/09/1994	EP		X
	AQ	0 507 497	10/07/1992	EP		X
	AR	0 918 100	05/26/1999	EP		X
	AS	10 236899	09/08/1998	JP		X
	AT					
	AU					
	AV					

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

	AW	R. SAMLENSKI ET AL., "Incorporation of nitrogen in chemical vapor deposition diamond" applied physics letters, vol. 67. no. 19, pages 2798-2800.				
	AX					
	AY					
	AZ				<input type="checkbox"/> Additional References sheet(s) attached	

Examiner

Date Considered

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.